

Notice of References Cited	Application/Control No. 10/602,467	Applicant(s)/Patent Under Reexamination SELVAMANICKAM ET AL.	
	Examiner Brian K Talbot	Art Unit 1762	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,432,151	07-1995	Russo et al.	505/474
	C	US-6,214,772	04-2001	Iijima et al.	505/475
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	E	US-6,797,313	09-2004	Fritzemeier et al.	427/62
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	N	04-331,795	11-1992	Japan		
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	V	Biaxially Aligned YSZ Buffer Layer on Polycrystalline Substrates, Iijima et al., International Symposium on Superconductivity, Oct. 14-17 1991, Tokyo Japan, pp. 1-4				
	W	Structural and Transport properties of Biaxially aligned YBACUO film on Polycrystalline Ni-based alloy with Ion Beam Modified buffer layers, Iijima et al., Journal of Applied Physics, vol. 73(3) August 1, 1993, pp. 1905-1911				
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.